

Notice of References Cited	Application/Control No. 10/622,688	Applicant(s)/Patent Under Reexamination KIDA ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,738,124 b2	05-2004	Park et al.	349/153
	B	US-2001/0015786 a1	08-2001	Katsura, Hideki	349/153
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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